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MICRO-MIRROR DEVICE WITH LIGHT ANGLE AMPLIFICATION

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Cross-Reference to Related Applications

15 This application is a Continuation-In-Part of copending U.S. Patent
Application Serial No. 10/136,719, filed on April 30, 2002, assigned to the
assignee of the present invention, and incorporated herein by reference.

The Field of the Invention

20 The present invention relates generally to micro-actuators, and more
particularly to a micro-mirror device.

Background of the Invention

25 Micro-actuators have been formed on insulators or other substrates using
micro-electronic techniques such as photolithography, vapor deposition, and
etching. Such micro-actuators are often referred to as micro-electromechanical
systems (MEMS) devices. An example of a micro-actuator includes a micro-
mirror device. The micro-mirror device can be operated as a light modulator for
30 amplitude and/or phase modulation of incident light. One application of a micro-
mirror device is in a display system. As such, multiple micro-mirror devices are

arranged in an array such that each micro-mirror device provides one cell or pixel of the display.

A conventional micro-mirror device includes an electrostatically actuated mirror supported for rotation about an axis of the mirror. As such, rotation of the mirror about the axis may be used to modulate incident light by directing or reflecting the incident light in different directions. To effectively direct the incident light in different directions, the angle of the reflected light must be sufficient. The angle of the reflected light may be increased, for example, by increasing the angle of rotation or tilt of the mirror. Increasing the angle of rotation or tilt of the mirror, however, may fatigue the mirror and/or produce slower response times since the mirror will be rotated or tilted over a larger distance.

Accordingly, it is desired to effectively increase an angle of reflected light from the micro-mirror device without having to increase rotation or tilt of the mirror of the micro-mirror device.

Summary of the Invention

One aspect of the present invention provides a micro-mirror device. The micro-mirror device includes a substrate and a plate spaced from and oriented substantially parallel to the substrate such that the plate and the substrate define a cavity therebetween. A reflective element is interposed between the substrate and the plate, and a liquid having an index of refraction greater than one is disposed in the cavity between at least the reflective element and the plate. As such, the reflective element is adapted to move between a first position and at least one second position.

Brief Description of the Drawings

Figure 1 is a schematic cross-sectional view illustrating one embodiment of a portion of a micro-mirror device according to the present invention.

Figure 2 is a perspective view illustrating one embodiment of a portion of a micro-mirror device according to the present invention.

Figure 3 is a perspective view illustrating another embodiment of a portion of a micro-mirror device according to the present invention.

Figure 4 is a schematic cross-sectional view taken along line 4-4 of Figures 2 and 3 illustrating one embodiment of actuation of a micro-mirror device according to the present invention.

Figure 5 is a schematic cross-sectional view illustrating one embodiment of light modulation by a micro-mirror device according to the present invention.

10 Figure 6 is a schematic cross-sectional view illustrating one embodiment of light modulation by a conventional micro-mirror device.

Figure 7 is a schematic cross-sectional view illustrating another embodiment of light modulation by a micro-mirror device according to the present invention.

15 Figure 8 is a schematic cross-sectional view illustrating another embodiment of light modulation by a conventional micro-mirror device.

Figure 9 is a schematic cross-sectional view illustrating another embodiment of light modulation by a micro-mirror device according to the present invention.

20 Figure 10 is a block diagram illustrating one embodiment of a display system including a micro-mirror device according to the present invention.

Figure 11 is a block diagram illustrating one embodiment of an optical switch including a micro-mirror device according to the present invention.

25 Description of the Preferred Embodiments

In the following detailed description of the preferred embodiments, reference is made to the accompanying drawings which form a part hereof, and in which is shown by way of illustration specific embodiments in which the invention may be practiced. In this regard, directional terminology, such as “top,” “bottom,” “front,” “back,” “leading,” “trailing,” etc., is used with reference to the orientation of the Figure(s) being described. Because components of the

present invention can be positioned in a number of different orientations, the directional terminology is used for purposes of illustration and is in no way limiting. It is to be understood that other embodiments may be utilized and structural or logical changes may be made without departing from the scope of the present invention. The following detailed description, therefore, is not to be taken in a limiting sense, and the scope of the present invention is defined by the appended claims.

Figure 1 illustrates one embodiment of a micro-mirror device 10. Micro-mirror device 10 is a micro-actuator which relies on electrical to mechanical conversion to generate a force and cause movement or actuation of a body or element. In one embodiment, as described below, a plurality of micro-mirror devices 10 are arranged to form an array of micro-mirror devices. As such, the array of micro-mirror devices may be used to form a display. As such, each micro-mirror device 10 constitutes a light modulator for modulation of incident light and provides one cell or pixel of the display. In addition, micro-mirror device 10 may also be used in other imaging systems such as projectors or printers, and may also be used for optical addressing or switching, and/or other optical beam modification.

In one embodiment, micro-mirror device 10 includes a substrate 20, a plate 30, and an actuating element 40. Preferably, plate 30 is oriented substantially parallel to a surface 22 of substrate 20 and spaced from surface 22 so as to define a cavity 50 therebetween. Actuating element 40 is interposed between surface 22 of substrate 20 and plate 30. As such, actuating element 40 is positioned within cavity 50.

In one embodiment, actuating element 40 is actuated so as to move between a first position 47 and a second position 48 relative to substrate 20 and plate 30. Preferably, actuating element 40 moves or tilts at an angle about an axis of rotation. As such, first position 47 of actuating element 40 is illustrated as being substantially horizontal and substantially parallel to substrate 20 and second position 48 of actuating element 40 is illustrated as being oriented at an angle to first position 47. Movement or actuation of actuating element 40 relative to substrate 20 and plate 30 is described in detail below.

In one embodiment, cavity 50 is filled with a liquid 52 such that actuating element 40 is in contact with liquid 52. More specifically, regardless of the orientation of micro-mirror device 10, cavity 50 is filled with liquid 52 such that liquid 52 is disposed between at least actuating element 40 and plate 30. In one embodiment, cavity 50 is filled with liquid 52 such that actuating element 40 is submerged in liquid 52. Liquid 52, therefore, is disposed between actuating element 40 and substrate 20 and between actuating element 40 and plate 30. Thus, liquid 52 contacts or wets opposite surfaces of actuating element 40.

Preferably, liquid 52 is transparent. As such, liquid 52 is clear or colorless in the visible spectrum. In addition, liquid 52 is chemically stable in electric fields, thermally stable with a wide temperature operating range, and photochemically stable. In addition, liquid 52 has a low vapor pressure and is non-corrosive.

In one embodiment, liquid 52 includes a dielectric liquid 53. Dielectric liquid 53 enhances actuation of actuating element 40, as described below. Preferably, dielectric liquid 53 has a high polarizability in electric fields and moves in a non-uniform electric field. In addition, dielectric liquid 53 has a low dielectric constant and a high dipole moment. In addition, dielectric liquid 53 is generally flexible and has pi electrons available. Examples of liquids suitable for use as dielectric liquid 53 include phenyl-ethers, either alone or in blends (i.e., 2, 3, and 5 ring), phenyl-sulphides, and/or phenyl-selenides. In one illustrative embodiment, examples of liquids suitable for use as dielectric liquid 53 include a polyphenyl ether (PPE) such as OS138 and olive oil.

Preferably, plate 30 is a transparent plate 32 and actuating element 40 is a reflective element 42. In one embodiment, transparent plate 32 is a glass plate. Other suitable planar translucent or transparent materials, however, may be used. Examples of such a material include quartz and plastic.

Reflective element 42 includes a reflective surface 44. In one embodiment, reflective element 42 is formed of a uniform material having a suitable reflectivity to form reflective surface 44. Examples of such a material include polysilicon or a metal such as aluminum. In another embodiment, reflective element 42 is formed of a base material such as polysilicon with a

reflective material such as aluminum or titanium nitride disposed on the base material to form reflective surface 44. In addition, reflective element 42 may be formed of a non-conductive material or may be formed of or include a conductive material.

5 As illustrated in the embodiment of Figure 1, micro-mirror device 10 modulates light generated by a light source (not shown) located on a side of transparent plate 32 opposite of substrate 20. The light source may include, for example, ambient and/or artificial light. As such, input light 12, incident on transparent plate 32, passes through transparent plate 32 into cavity 50 and is
10 reflected by reflective surface 44 of reflective element 42 as output light 14. Thus, output light 14 passes out of cavity 50 and back through transparent plate 32.

 The direction of output light 14 is determined or controlled by the position of reflective element 42. For example, with reflective element 42 in first position
15 47, output light 14 is directed in a first direction 14a. However, with reflective element 42 in second position 48, output light 14 is directed in a second direction 14b. Thus, micro-mirror device 10 modulates or varies the direction of output light 14 generated by input light 12. As such, reflective element 42 can be used to steer light into, and/or away from, an optical imaging system.

20 In one embodiment, first position 47 is a neutral position of reflective element 42 and represents an "ON" state of micro-mirror device 10 in that light is reflected, for example, to a viewer or onto a display screen, as described below. Thus, second position 48 is an actuated position of reflective element 42 and represents an "OFF" state of micro-mirror device 10 in that light is not
25 reflected, for example, to a viewer or onto a display screen.

 Figure 2 illustrates one embodiment of reflective element 42. Reflective element 142 has a reflective surface 144 and includes a substantially rectangular-shaped outer portion 180 and a substantially rectangular-shaped inner portion 184. In one embodiment, reflective surface 144 is formed on both
30 outer portion 180 and inner portion 184. Outer portion 180 has four contiguous side portions 181 arranged to form a substantially rectangular-shaped opening

182. As such, inner portion 184 is positioned within opening 182. Preferably, inner portion 184 is positioned symmetrically within opening 182.

In one embodiment, a pair of hinges 186 extend between inner portion 184 and outer portion 180. Hinges 186 extend from opposite sides or edges of inner portion 184 to adjacent opposite sides or edges of outer portion 180. Preferably, outer portion 180 is supported by hinges 186 along an axis of symmetry. More specifically, outer portion 180 is supported about an axis that extends through the middle of opposed edges thereof. As such, hinges 186 facilitate movement of reflective element 142 between first position 47 and second position 48, as described above (Figure 1). More specifically, hinges 186 facilitate movement of outer portion 180 between first position 47 and second position 48 relative to inner portion 184.

In one embodiment, hinges 186 include torsional members 188 having longitudinal axes 189 oriented substantially parallel to reflective surface 144. Longitudinal axes 189 are collinear and coincide with an axis of symmetry of reflective element 142. As such, torsional members 188 twist or turn about longitudinal axes 189 to accommodate movement of outer portion 180 between first position 47 and second position 48 relative to inner portion 184.

In one embodiment, reflective element 142 is supported relative to substrate 20 by a support or post 24 extending from surface 22 of substrate 20. More specifically, post 24 supports inner portion 184 of reflective element 142. As such, post 24 is positioned within side portions 181 of outer portion 180. Thus, outer portion 180 of reflective element 142 is supported from post 24 by hinges 186.

Figure 3 illustrates another embodiment of reflective element 42. Reflective element 242 has a reflective surface 244 and includes a substantially H-shaped portion 280 and a pair of substantially rectangular-shaped portions 284. In one embodiment, reflective surface 244 is formed on both H-shaped portion 280 and rectangular-shaped portions 284. H-shaped portion 280 has a pair of spaced leg portions 281 and a connecting portion 282 extending between spaced leg portions 281. As such, rectangular-shaped portions 284 are positioned on opposite sides of connection portion 282 between spaced leg

portions 281. Preferably, rectangular-shaped portions 284 are positioned symmetrically to spaced leg portions 281 and connecting portion 282.

In one embodiment, hinges 286 extend between rectangular-shaped portions 284 and H-shaped portion 280. Hinges 286 extend from a side or edge
5 of rectangular-shaped portions 284 to adjacent opposite sides or edges of connecting portion 282 of H-shaped portion 280. Preferably, H-shaped portion 280 is supported by hinges 286 along an axis of symmetry. More specifically, H-shaped portion 280 is supported about an axis that extends through the middle of opposed edges of connecting portion 282. As such, hinges 286
10 facilitate movement of reflective element 242 between first position 47 and second position 48, as described above (Figure 1). More specifically, hinges 286 facilitate movement of H-shaped portion 280 between first position 47 and second position 48 relative to rectangular-shaped portions 284.

In one embodiment, hinges 286 include torsional members 288 having
15 longitudinal axes 289 oriented substantially parallel to reflective surface 244. Longitudinal axes 289 are collinear and coincide with an axis of symmetry of reflective element 242. As such, torsional members 288 twist or turn about longitudinal axes 289 to accommodate movement of H-shaped portion 280 between first position 47 and second position 48 relative to rectangular-shaped
20 portions 284.

In one embodiment, reflective element 242 is supported relative to substrate 20 by a pair of posts 24 extending from surface 22 of substrate 20. More specifically, posts 24 support rectangular-shaped portions 284 of reflective
25 element 242. As such, posts 24 are positioned on opposite sides of connecting portion 282 between spaced leg portions 281. Thus, H-shaped portion 280 of reflective element 242 is supported from posts 24 by hinges 286.

Figure 4 illustrates one embodiment of actuation of micro-mirror device
10. In one embodiment, reflective element 42 (including reflective elements 142 and 242) is moved between first position 47 and second position 48 by applying
30 an electrical signal to an electrode 60 formed on substrate 20. In one embodiment, electrode 60 is formed on surface 22 of substrate 20 adjacent an end or edge of reflective element 42. Application of an electrical signal to

electrode 60 generates an electric field between electrode 60 and reflective element 42 which causes movement of reflective element 42 between first position 47 and second position 48. As such, reflective element 42 is moved in a first direction.

5 Preferably, dielectric liquid 53 is selected so as to respond to the electric field. More specifically, dielectric liquid 53 is selected such that the electric field aligns and moves polar molecules of the liquid. As such, dielectric liquid 53 moves in the electric field and contributes to the movement of reflective element 42 between first position 47 and second position 48 upon application of the
10 electrical signal. Thus, with dielectric liquid 53 in cavity 50, dielectric liquid 53 enhances an actuation force acting on reflective element 42 as described, for example, in related U.S. Patent Application Serial No. 10/136,719, assigned to the assignee of the present invention.

 Preferably, when the electrical signal is removed from electrode 60,
15 reflective element 42 persists or holds second position 48 for some length of time. Thereafter, restoring forces of reflective element 42 including, for example, hinges 186 (Figure 2) and hinges 286 (Figure 3) pull or return reflective element 42 to first position 47.

 In one embodiment, a conductive via 26 is formed in and extends through
20 post 24. Conductive via 26 is electrically coupled to reflective element 42 and, more specifically, conductive material of reflective element 42. As such, reflective element 42 (including reflective elements 142 and 242) is moved between first position 47 and second position 48 by applying an electrical signal to electrode 60 and reflective element 42. More specifically, electrode 60 is
25 energized to one electrical potential and the conductive material of reflective element 42 is energized to a different electrical potential.

 Application of one electrical potential to electrode 60 and a different electrical potential to reflective element 42 generates an electric field between electrode 60 and reflective element 42 which causes movement of reflective
30 element 42 between first position 47 and second position 48. Dielectric liquid 53 contributes to the movement of reflective element 42, as described above.

In another embodiment, reflective element 42 (including reflective elements 142 and 242) is moved between first position 47 and second position 48 by applying an electrical signal to reflective element 42. More specifically, the electrical signal is applied to conductive material of reflective element 42 by way of conductive via 26 through post 24. As such, application of an electrical signal to reflective element 42 generates an electric field which causes movement of reflective element 42 between first position 47 and second position 48. Dielectric liquid 53 contributes to the movement of reflective element 42, as described above.

Additional embodiments of actuation of micro-mirror device 10 are described, for example, in related U.S. Patent Application Serial No. 10/136,719, assigned to the assignee of the present invention.

In one embodiment, as illustrated in Figure 4, reflective element 42 is also moved in a second direction opposite the first direction. More specifically, reflective element 42 is moved between first position 47 and a third position 49 oriented at an angle to first position 47 by applying an electrical signal to an electrode 62 formed on substrate 20 adjacent an opposite end or edge of reflective element 42. As such, reflective element 42 is moved in the second direction opposite the first direction by application of an electrical signal to electrode 62.

Application of the electrical signal to electrode 62 generates an electric field between electrode 62 and reflective element 42 which causes movement of reflective element 42 between first position 47 and third position 49 in a manner similar to how reflective element 42 moves between first position 47 and second position 48, as described above. It is also within the scope of the present invention for reflective element 42 to move directly between second position 48 and third position 49 without stopping or pausing at first position 47.

In one embodiment, liquid 52 (including dielectric liquid 53) contained within cavity 50 of micro-mirror device 10 has an index of refraction greater than one. In addition, air which surrounds micro-mirror device 10 has an index of refraction which is substantially one. As such, regions having different indexes

of refraction are formed within cavity 50 of micro-mirror device 10 and outside of cavity 50 of micro-mirror device 10.

Because of the different indexes of refraction, a light ray modulated by micro-mirror device 10 undergoes refraction at the interface between the two regions. More specifically, input light which passes through plate 30 and into cavity 50 undergoes refraction at the interface with cavity 50. In addition, output light which is reflected by reflective element 42 and from cavity 50 through plate 30 undergoes refraction at the interface with cavity 50. In one embodiment, a material of plate 30 is selected so as to have an index of refraction substantially equal to that of liquid 52. In addition, a thickness of plate 30 is substantially thin such that refraction at plate 30 is negligible. In one exemplary embodiment, the thickness of plate 30 is approximately one millimeter.

In one illustrative embodiment, the index of refraction of liquid 52 contained within cavity 50 of micro-mirror device 10 is in a range of approximately 1.3 to approximately 1.7. Examples of liquids suitable for use as liquid 52 include diphenyl ether, diphenyl ethylene, polydimethyl siloxane, or tetraphenyl-tetramethyl-trisiloxane. These and other liquids suitable for use as liquid 52 are described, for example, in U.S. Patent Application Serial No. _____, having attorney docket number 200209446, and U.S. Patent Application Serial No. _____, having attorney docket number 200308966, both filed on even date herewith, assigned to the assignee of the present invention, and incorporated herein by reference.

Referring to Figure 5, for a light ray intersecting a plane surface interface, Snell's Law holds that:

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$$n_1 \sin(A_1) = n_2 \sin(A_2)$$

where n_1 represents the index of refraction on a first side of the plane surface interface, A_1 represents the included angle formed on the first side of the plane surface interface between the light ray and a line perpendicular to the plane surface interface through a point where the light ray intersects the plane surface interface, n_2 represents the index of refraction on a second side of the

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plane surface interface, and A2 represents the included angle formed on the second side of the plane surface interface between the light ray and the line perpendicular to the plane surface interface through the point where the light ray intersects the plane surface interface.

5 Figure 5 illustrates one embodiment of input light 12 passing through plate 30 into cavity 50 and being reflected as output light 14 from cavity 50 back through plate 30. In one embodiment, as described above, liquid 52 within cavity 50 has an index of refraction greater than one and, more specifically, greater than the air outside of cavity 50. As such, input light 12 undergoes
10 refraction at the interface with cavity 50 as input light 12 enters cavity 50 and output light 14 undergoes refraction at the interface with cavity 50 as output light 14 leaves cavity 50.

 In one embodiment, an angle A1 is formed outside of cavity 50 between input light 12 and a line extended perpendicular to an interface with cavity 50
15 through a point where input light 12 intersects the interface. Angle A1, therefore, represents an illumination angle of input light 12. In addition, an angle A2 is formed within cavity 50 between input light 12 and the line extended perpendicular to the interface with cavity 50 through the point where input light 12 intersects the interface. Angle A2, therefore, represents an illumination
20 refraction angle of input light 12.

 As described above, input light 12 is reflected as output light 14 by reflective element 42. As such, an angle A3 is formed within cavity 50 between output light 14 and a line extended parallel to the line extended perpendicular to the interface with cavity 50 through the point where input light 12 intersects the
25 interface through a point where input light 12 is reflected by reflective element 42. Angle A3, therefore, represents a reflection angle of output light 14. In addition, an angle A4 is formed outside of cavity 50 between output light 14 and a line extended perpendicular to an interface with cavity 50 through a point where output light 14 intersects the interface. Angle A4, therefore, represents
30 an exit angle of output light 14.

 By applying optics fundamentals, including refraction at the interface with cavity 50 and reflection at reflective element 42, exit angle A4 can be derived for

varying tilt angles of reflective element 42, represented by angle A5, and differing indexes of refraction of liquid 52 within cavity 50, represented by index of refraction n_2 . As described above, the index of refraction of air surrounding micro-mirror device 10, represented by index of refraction n_1 , is substantially one.

Figures 6 and 7 illustrate one exemplary embodiment of modulation of light by a micro-mirror device without and with, respectively, a liquid having an index of refraction greater than one disposed within cavity 50. Figure 6 illustrates modulation of light by a micro-mirror device without a liquid having an index of refraction greater than one disposed within cavity 50. In the exemplary embodiment of Figure 6, cavity 50 does not include liquid 52 but, rather, includes air. As such, the index of refraction within cavity 50 is substantially one. Since the index of refraction outside of the micro-mirror device is also substantially one, refraction does not occur at the interface with cavity 50 assuming that a thickness of plate 30 is substantially thin, as described above. In the exemplary embodiment of Figure 6, illumination angle A1 of input light 12 is 15 degrees and tilt angle A5 of reflective element 42 is 5 degrees. As such, exit angle A4 of output light 14 is 25 degrees.

Figure 7 illustrates modulation of light by a micro-mirror device with a liquid having an index of refraction greater than one disposed within cavity 50. In the exemplary embodiment of Figure 7, cavity 50 includes liquid 52 (including dielectric liquid 53) having an index of refraction of 1.65. In addition, for comparison with Figure 6, illumination angle A1 of input light 12 is 15 degrees and tilt angle A5 of reflective element 42 is 5 degrees. Exit angle A4 of output light 14, however, is 32.5 degrees. As such, with the same illumination angle (15 degrees) of input light 12 and the same tilt angle (5 degrees) of reflective element 42, a larger exit angle for output light 14 can be achieved with liquid 52 disposed within cavity 50. Thus, for example, a 30 percent increase (7.5 degrees) in the exit angle of output light 14 from cavity 50 can be achieved without an increase in the tilt angle of reflective element 42 when cavity 50 includes liquid 52. This increase in exit angle is referred to herein as angle magnification.

Figure 8 illustrates another exemplary embodiment of modulation of light by a micro-mirror device without a liquid having an index of refraction greater than one disposed within cavity 50. In the exemplary embodiment of Figure 8, cavity 50 does not include liquid 52 but, rather, includes air. The index of
5 refraction within cavity 50, therefore, is substantially one. Since the index of refraction outside of the micro-mirror device is also substantially one, angle magnification does not occur at the interface with cavity 50.

In the exemplary embodiment of Figure 8, illumination angle A1 of input light 12 is 15 degrees and tilt angle A5 of reflective element 42 is 5 degrees. As
10 such, without liquid 52 disposed within cavity 50 and with the same illumination angle (15 degrees) of input light 12, to produce exit angle A4 of output light 14 with the same exit angle (32.5 degrees) as illustrated in Figure 7, tilt angle A5 of reflective element 42 must be increased to 8.75 degrees. Thus, for example, a
75 percent increase (3.75 degrees) in the tilt angle of reflective element 42 is
15 needed to produce the same exit angle of output light 14 from cavity 50 when cavity 50 does not include liquid 52.

Figure 9 illustrates another exemplary embodiment of modulation of light by a micro-mirror device with a liquid having an index of refraction greater than one disposed within cavity 50. In the exemplary embodiment of Figure 9, cavity
20 50 includes liquid 52 (including dielectric liquid 53) having an index of refraction of 1.65. In addition, illumination angle A1 of input light 12 is 15 degrees. As such, with liquid 52 disposed in cavity 50 and with the same illumination angle (15 degrees) of input light 12, to produce exit angle A4 of output light 14 with the same exit angle (25 degrees) as illustrated in Figure 6, tilt angle A5 of reflective
25 element 42 need only be 2.9 degrees. Thus, for example, a 42 percent decrease (2.1 degrees) in the tilt angle of reflective element 42 can produce the same exit angle of output light 14 from cavity 50 when cavity 50 includes liquid 52.

In one embodiment, as illustrated in Figure 10, micro-mirror device 10 is
30 incorporated in a display system 500. Display system 500 includes a light source 510, source optics 512, a light processor or controller 514, and projection optics 516. Light processor 514 includes multiple micro-mirror

devices 10 arranged in an array such that each micro-mirror device 10 constitutes one cell or pixel of the display. The array of micro-mirror devices 10 may be formed on a common substrate with separate cavities and/or a common cavity for the reflective elements of the multiple micro-mirror devices 10.

5 In one embodiment, light processor 514 receives image data 518 representing an image to be displayed. As such, light processor 514 controls the actuation of micro-mirror devices 10 and the modulation of light received from light source 510 based on image data 518. The modulated light is then projected to a viewer or onto a display screen 520.

10 In one embodiment, as illustrated in Figure 11, micro-mirror device 10 is incorporated in an optical switching system 600. Optical switching system 600 includes a light source 610, a light processor or controller 612, and at least one receiver 614. Light processor 612 includes one or more micro-mirror devices 10 configured to selectively direct light to receiver 614. Light source 610 may
15 include, for example, an optical fiber, laser, light emitting diode (LED), or other light emitting device for producing input light 12. Receiver 614 may include, for example, an optical fiber, light pipe/channel, or other optical receiving or detecting device.

 In one embodiment, receiver 614 includes a first receiver 614a and a
20 second receiver 614b. As such, light processor 612 controls actuation of micro-mirror device 10 and the modulation of light received from light source 610 to direct light to first receiver 614a or second receiver 614b. For example, when micro-mirror device 10 is in a first position, output light 14a is directed to first receiver 614a and, when micro-mirror device 10 is in a second position, output
25 light 14b is directed to second receiver 614b. As such, optical switching system 600 controls or directs light with micro-mirror device 10 for use, for example, in optical addressing or switching.

 By disposing liquid 52 (including dielectric liquid 53) having an index of refraction greater than one within cavity 50, an exit angle of output light 14 from
30 micro-mirror device 10 can be increased or amplified without having to increase the tilt angle of reflective element 42. By increasing the exit angle of output light 14 from micro-mirror device 10, incident light can be more effectively modulated

between being directed completely on and completely off the projection optics of the display device. As such, a contrast ratio of the display device can be increased.

5 In addition, by producing a desired exit angle of output light 14 from micro-mirror device 10 with a smaller tilt angle of reflective element 42, the apparent tilt angle of reflective element 42 can be greater than the actual tilt angle of reflective element 42. Thus, faster response or actuation times of micro-mirror device 10 can be achieved since reflective element 42 can be rotated or tilted through a smaller distance while still producing the desired exit
10 angle of output light 14 from micro-mirror device 10. Furthermore, micro-mirror device 10 may be subjected to less fatigue since reflective element 42 can be rotated or tilted through the smaller distance while still producing the desired exit angle of output light 14 from micro-mirror device 10.

Although specific embodiments have been illustrated and described
15 herein for purposes of description of the preferred embodiment, it will be appreciated by those of ordinary skill in the art that a wide variety of alternate and/or equivalent implementations calculated to achieve the same purposes may be substituted for the specific embodiments shown and described without departing from the scope of the present invention. Those with skill in the
20 chemical, mechanical, electro-mechanical, electrical, and computer arts will readily appreciate that the present invention may be implemented in a very wide variety of embodiments. This application is intended to cover any adaptations or variations of the preferred embodiments discussed herein. Therefore, it is manifestly intended that this invention be limited only by the claims and the
25 equivalents thereof.

What is Claimed is:

CLAIMS

1. A micro-mirror device, comprising:
a substrate (20);
a plate (30) spaced from and oriented substantially parallel to the substrate, the plate and the substrate defining a cavity (50) therebetween;
a reflective element (42) interposed between the substrate and the plate;
and
a liquid (52/53) having an index of refraction greater than one disposed in the cavity between at least the reflective element and the plate,
wherein the reflective element is adapted to move between a first position and at least one second position.
2. The device of claim 1, wherein the at least one second position is oriented at an angle to the first position.
3. The device of claim 1, wherein the reflective element is adapted to reflect light through the liquid, and the liquid is adapted to increase an exit angle (A4) of the light from the cavity for a given tilt angle (A5) of the reflective element.
4. The device of claim 1, wherein the reflective element is adapted to reflect light through the liquid, and the liquid is adapted to produce an exit angle (A4) of the light from the cavity corresponding to a tilt angle of the reflective element greater than an actual tilt angle (A5) of the reflective element.
5. The device of claim 1, wherein the index of refraction of the liquid is in a range of approximately 1.3 to approximately 1.7.
6. The device of claim 1, wherein the reflective element is submerged in the liquid.

7. The device of claim 1, further comprising:
at least one electrode (60, 62) formed on the substrate,
wherein the reflective element is adapted to move in response to
application of an electrical signal to the at least one electrode.
8. A method of forming a micro-mirror device, the method comprising:
providing a substrate (20);
orienting a plate (30) substantially parallel to the substrate and spacing
the plate from the substrate, including defining a cavity (50) between the plate
and the substrate;
interposing a reflective element (42) between the substrate and the plate;
and
disposing a liquid (52/53) having an index of refraction greater than one
in the cavity between at least the reflective element and the plate,
wherein the reflective element is adapted to move between a first position
and at least one second position.
9. The method of claim 8, wherein the at least one second position is
oriented at an angle to the first position.
10. The method of claim 8, wherein the reflective element is adapted to
reflect light through the liquid and the liquid is adapted to increase an exit angle
(A4) of the light from the cavity for a given tilt angle (A5) of the reflective
element.
11. The method of claim 8, wherein the reflective element is adapted to
reflect light through the liquid and the liquid is adapted to produce an exit angle
(A4) of the light from the cavity corresponding to a tilt angle of the reflective
element greater than an actual tilt angle (A5) of the reflective element.

12. The method of claim 8, wherein the index of refraction of the liquid is in a range of approximately 1.3 to approximately 1.7.

13. The method of claim 8, wherein interposing the reflective element between the substrate and the plate includes submerging the reflective element in the liquid.

14. The method of claim 8, further comprising:
forming at least one electrode (60, 62) on the substrate,
wherein the reflective element is adapted to move in response to
application of an electrical signal to the at least one electrode.

15. A method of controlling light with a micro-mirror device (10) including a reflective element (42), the method comprising:
receiving light at the reflective element; and
reflecting the light with the reflective element, including directing the light through a liquid (52/53) having an index of refraction greater than one and through an interface with the liquid,
wherein directing the light through the interface with the liquid includes refracting the light at the interface with the liquid.

16. The method of claim 15, wherein refracting the light at the interface with the liquid includes amplifying an exit angle of the light from the liquid for a given tilt angle of the reflective element.

17. The method of claim 15, wherein refracting the light at the interface with the liquid includes exiting the light from the liquid with an exit angle (A4) corresponding to an apparent tilt angle of the reflective element greater than an actual tilt angle (A5) of the reflective element.

18. The method of claim 15, wherein the index of refraction of the liquid is in a range of approximately 1.3 to approximately 1.7.

19. The method of claim 15, further comprising:

moving the reflective element between a first position and at least one second position oriented at an angle to the first position, including directing the light in a first direction when the reflective element is in the first position and directing the light in a second direction when the reflective element is in the at least one second position.